

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tomoko MIYAHARA et al.

Application No.: New U.S. Patent Application

Filed: February 2, 2004

Docket No.: 118505

For: CARBON NANOTUBE MANUFACTURING APPARATUS AND METHOD, AND
GAS DECOMPOSER FOR USE IN THE MANUFACTURING APPARATUS AND
METHOD

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Claims as reflected in the listing of claims;

Remarks.